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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:		Docket No.:	2771-688
Applicants:	KING, Mackenzie, et al.	Conf. No.:	7009
Application No.:	10/722,174	Art Unit:	1742
Date Filed:	November 25, 2003	Examiner:	Nicholas A. Smith
Title:	ON-WAFER ELECTROCHEMICAL DEPOSITION PLATING METROLOGY PROCESS AND APPARATUS	Customer No.:	23448

FACSIMILE TRANSMISSION CERTIFICATE ATTN: Examiner Nicholas A. Smith Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission, addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1459, and transmitted on the date specified below, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

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Number of Pag	es MM
Steven J. Hultqu	nist
September 4, 20	07
Date	

RESPONSE TO JUNE 5, 2007 OFFICE ACTION IN U.S. PATENT APPLICATION NO. 10/722,174

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

2771-688

This responds to the June 5, 2007 Office Action in the above-identified application.

A listing of the claims of the application is set out in Section I (Listing of the Claims) beginning at page 3 hereof.

Remarks concerning the substance of the June 5, 2007 Office Action are set out in Section II (Remarks) beginning at page 9 hereof.